

10050639  
01/15/02

U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10050639	01/15/2002	436		1765	

\*\*APPLICANTS: Lee Whonchee; Hu Yongjun;

\*\*CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CON OF 09/560,268 04/26/2000  
WHICH IS A DIV OF 08/914,935 08/20/1997 PAT 6,074,960

\*\* FOREIGN APPLICATIONS VERIFIED:

PG-PUB ☐ DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no


Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

150.00560104

TITLE : Method and composition for selectively etching against cobalt silicide

U.S. DEPT. OF COMM./PAT. & TM.-PTO-4361 (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>Assistant Examiner</b>	<b>CLAIMS ALLOWED</b>	
			<b>Total Claims</b>	<b>Print Claim for O.G.</b>
<b>ISSUE FEE</b>		<b>Primary Examiner</b>	<b>DRAWING</b>	
<b>Amount Due</b>	<b>Date Paid</b>		<b>Sheets Drwg.</b>	<b>Figs.Drwg.</b>
 <b>TERMINAL DISCLAIMER</b>  6,074,960		<b>PREPARED FOR ISSUE</b>	<b>Application Examiner</b>	
		<b>WARNING:</b> The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.		

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